



## IN THE US PATENT AND TRADEMARK OFFICE

Application Number: 09/932,433  
Agent's Docket Number ONX-115A/DIV  
Filing Date: August 18, 2001  
Applicants: Murali Chaparala, et al.  
Application Title: USE OF APPLIED FORCE TO IMPROVE MEMS  
SWITCH PERFORMANCE  
Examiner: Elizabeth M. Gemmel  
Art Unit: 2882

### Certificate of Mailing by "EXPRESS MAIL"

I hereby certify that I am mailing this correspondence on the date indicated below to the MAIL STOP FEE AMENDMENT, COMMISSIONER FOR PATENTS, P.O. Box 1450, Alexandria, VA 22313-1450 using the "Express Mail Post Office to Addressee" service of the United States Postal Service under 37 CFR 1.10.

<u>Bing Li</u> <b>SIGNATURE</b>	<b>DATE OF MAILING</b>	<b>9/30/2003</b>
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### OFFICE ACTION RESPONSE

15 Commissioner of Patents and Trademarks  
Washington, DC 20231

Sir:

In response to the Office Action mailed March 31, 2003, kindly amend the application as follows and consider the following remarks:

20 **REMARKS** begin on page 2 of this paper.

**ATTACHMENTS** (Terminal Disclaimer and 2 Declarations) begin after page 4 of this paper.

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